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Session 1 Presentation 2

TestConX China 2020

New Horizons

Advantages and Opportunities with MEMS wafer level final test

Michael Siebert Afore Oy



Virtual - October 27-29, 2020



TestConX China Workshop

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New Horizons

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- Traditional MEMS packages
- Typical test / packaging flow
- Advanced package types
- Challenges and opportunities
- Solutions available today
- Conclusion



Advantages and Opportunities with MEMS wafer level final test



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New Horizons



New Horizons



New Horizons

Advanced package types

• WLP – Wafer Level Package (FO-WLP, WLCSP, ...)

- SiP System in Package
- SoC System on Chip





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New Horizons

Challenges and opportunities - WLP

- Size often 1 x 1 mm or below
 - Difficult to handle separated devices properly
 - > Mechanical alignment to stimulus (i. e. inertial sensors) and contacts challenging
- Low weight
 - > Makes handling in trays difficult without additional support
- Fragility
 - > Mechanical stress during conventional device test handling may cause damage to device
- ASIC and sensor join at wafer level
 - Opportunity to combine three separate test steps to one





New Horizons

How to move forward

- Improve available technology to allow handling of smaller parts and reduce mechanical stress
 - > Possible, but issues will return as dimensions continue to shrink
- Reduce number of process steps including device handling operations
 - Requires change to existing process flow
 - > Offers potential to streamline operations



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New Horizons



New Horizons

Advantages

- Elimination of several device handling and process steps
 - Reduced associated risks and yield losses
- Possibility to optimize test sequences as all components can be tested at once
 - Eliminate one sensor test step
 - Combine ASIC test with sensor test
- Reduced number of operator tasks
 - Less potential for error
 - Lower labor cost
- Reduction in floorspace





New Horizons

Challenges and opportunities- SIP / SOC

- Fragility of single components
 - Can cause components to fail due to handling stress
- System cost vs. sensor cost
 - Relatively cheap defective component can cause system to fail
- Gives opportunity to optimize test flow depending on component cost and complexity





New Horizons

How to move forward

- Sensor test and calibration at system level
 - Risk of SoC / SiP failures due to sensor malfunction

Known Good Die approach for sensor testing

- > Test sensors after dicing to ensure stress relieve before calibration
- > At wafer level on dicing frame to avoid unnecessary device handling
- Potentially adding short sensor verification to system level test of SoC/SiP





New Horizons



New Horizons

Advantages

Optimizing the process flow around test and packaging allows:

- > Minimizing yield losses due to bad components at system level
- Best utilization of Known Good Die at system level
- > Optimizing Cost of Test by minimizing test steps where possible



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New Horizons



- Probing of environmental sensors for
 - Pressure
 - Humidity
 - Gas concentration

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- ...

Using a production probe station with environmental chamber





New Horizons

Solutions available today

- Probing of motion sensors like
 - Gyroscopes
 - Accelerometers
 - Magnetometers
 - Combinations

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Using a production probe station with motion stimulus capability





New Horizons

Conclusion

- Overview to current MEMS final test handling strategies
- Challenges introduced with advanced packages
- Shown improved MEMS test handling strategies by
 - Combining wafer sort and final test for WLP
 - Replacement of wafer sort with wafer level final test for SiP/SoC



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